Applicant: Kouji Seki et al. Attorney's Docket No.: 14225-009002

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## Amendments to the Claims:

This listing of claims replaces all prior versions and listings of claims in the application:

## Listing of Claims:

## 1. -20. Canceled

21. (New) A semiconductor device manufacturing method comprising:
preparing an assembling apparatus comprising a cover, having an opening therein,
provided on a setting base comprising a heating function;

setting a plate-like substrate having conductive patterns mounted on the setting base; and mounting a semiconductor chip to the substrate or wire-bonding electrodes of the semiconductor chip to the conductive patterns through the opening,

wherein an illumination is disposed above the opening and a blowing device is provided at a periphery part of the illumination in order to prevent a fluctuation of an inert gas generated by the heating function from entering inside the illumination upon mounting or wire-bonding the semiconductor chip.

- 22. (New) The semiconductor device manufacturing method of claim 15, wherein the blowing device provides a blow current to escape the fluctuation.
- 23. (New) The semiconductor device manufacturing method of claim 16, wherein the fluctuation escapes in a horizontal direction.
- 24. (New) The semiconductor device manufacturing method of claim 15, wherein a part of the cover is formed of a clamper.

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25. (New) The semiconductor device manufacturing method of claim 18, wherein the inert gas is blown inside the cover through the clamper.

- 26. (New) The semiconductor device manufacturing method of claim 15, wherein the inert gas comprises nitrogen gas.
- 27. (New) The semiconductor device manufacturing method of claim 15, wherein a lens barrel is disposed above the illumination.
- 28. (New) The semiconductor device manufacturing method of claim 21, wherein a pattern recognition camera is disposed in the lens barrel.